

## Absolute Loss Measurement of Highly Reflective Samples by Using a High Q Gaussian Beam Open Resonator at Short Millimeter Wave Frequencies

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A high Q Gaussian beam open resonator and a new arrangement of it are described as a new method for determining absolute loss due to surface resistance of highly reflective materials at short millimeter- and sub-millimeter wave frequencies. The Gaussian beam open resonator consists of a pair of spherical mirrors with highly reflective partially transparent circular coupling regions and a plane mirror, where the plane mirror is the test sample. Application of this new method to reflection type measurement enabled simultaneous attainment of high Q factor and high signal-to-noise ratio, which would have been impossible using a conventional reflection-type open resonator with a small coupling hole. Moreover, the use of a pair of identical spherical mirrors enabled direct measurement of the Q of these mirrors, which is equal to  $Q_{\text{sub others}}$ , without changing the experimental conditions. Surface loss measurements of metal films are made at 100 GHz band. In the room temperature experiment, surface resistance of 110 m-Ohms was measured with an accuracy of  $\pm 7.6\%$ .

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